

PTO-1449 (PAGE 1 OF 1)

DOCKET NO. P56574

APPLICANT

HEE-CHUN PARK

FILING DATE 16 November 2001

GROUP *To be assigned.*

EXAMINER	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
AS	5,583,761	12/96	Chou	395	798	
AS	5,831,609	11/98	London <i>et al.</i>	345	335	
AS	5,974,372	10/99	Barnes <i>et al.</i>	704	8	
AS	6,092,036	07/00	Hamann	704	8	

TRANSLATION

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
AS	KR1995-27551	10/95	Korea			abstract	
AS	JP8-160930	06/96	Japan			abstract	
AS	JP9-114837	05/97	Japan			abstract	
AS	JP11-353074	12/99	Japan			abstract	
AS	JP2000-330992	11/00	Japan			abstract	
AS	JP2000-207399	07/00	Japan			abstract	


OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER:

DATE CONSIDERED:

12	08	2005
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE STATEMENT PTO-1449 (PAGE 1 OF 1) 	SERIAL NUMBER 09/987,950	DOCKET NO. P56574
	APPLICANT HEE-CHUN PARK	
	FILING DATE 16 November 2001	GROUP 2654

U.S. PATENT DOCUMENTS						
EXAMINER	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS						TRANSLATION	
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
AS	JP 2001-142600	5/01	JAPAN			Abstract	
AS	JP 09-081569	3/97	JAPAN			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)	
AS	Office Action from the Japanese Patent Office issued in Applicant's corresponding Korean Patent Application No. 2001-33188 (dated 25 January 2005).
AS	

EXAMINER: 	DATE CONSIDERED: 12/08/2005
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